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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Application of :  
Norio CHIBA et al. :  
Serial No. 10/692,345 : Group Art Unit - 1763  
Filed: October 23, 2003 : Examiner- Roberts P. Culbert  
For: METHOD OF MANUFACTURING :  
LIGHT-PROPAGATING PROBE :  
FOR NEAR-FIELD MICROSCOPE : Docket No. S005-5141

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MAIL STOP AMENDMENT  
COMMISSIONER FOR PATENTS  
P.O. Box 1450  
Alexandria, VA 22313-1450

*OK to Enter  
NLG/MA 8/1/07*

**SUPPLEMENTAL RESPONSE**

S I R:

In further response to the Office Action mailed November 22, 2006 and supplementing the response filed by mailing certificate date February 21, 2007, applicants further amend their application as follows:

**ADDITIONAL FEE:**

No additional fee is believed required in connection with this supplemental response. However, should it be determined that a fee is due, authorization is hereby given to charge any such fee to our Deposit Account No. 01-0268.

**MAILING CERTIFICATE ON PAGE 34**